Application Number 09 Docket Number (Optional) 005606/ETCH/SILICO Applicant(s) INFORMATION DISCLOSURE CITATION Anisul Khan et al. (Use several sheets if necessary) Group Art Unit Filing Date Filed Herewith Unassigne **U.S. PATENT DOCUMENTS** FILING DATE EXAMINER SUBCLASS CLASS DATE NAME DOCUMENT NUMBER INITIAL IF APPROPRIATE 7 438 4/1/86 Suzuki et al. 4,579,623 428 161 3/26/96 Laermer et al. 5,501,893 FOREIGN PATENT DOCUMENTS Translation CLASS SUBCLASS REF DOCUMENT NUMBER DATE COUNTRY YES NO H01L 21 306 4/18/90 **EPO** 0 363 982 A2 306 H01L 21 8/5/92 **EPO** 0 497 023 A1 OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) I.W. Rangelow, "High-resolution tri-level process by downstream-microwave RF-biased etching," SPIE, Vol.1392, Advanced Techniques for Integrated Circuit Processing (1990), pp. 180-184. 1 SA K. Tsujimoto et al., "A New Side Wall Protection Technique in Microwave Plasma Etching Using a Chopping Method", Abstracts of the 18th (1986 International) Conference on Solid State Devices and Materials, Tokyo, 1986, pp. 229-232. 2 SA DATE CONSIDERED **EXAMINER**

Form PTO-A820 (also form PTO-1449)

not considered. Include copy of this form with next communication to applicant.

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and

6103

Supplemental New York Control PE Docket Number (Optional) 005606/ETCH/SILICON Optional(1) About Khan et al.						Application Number 09/957,000		
Α΄		(Use several sheets if necessor	1977)	Appeul Khan et al. 2 2 200 Pare 9/19/0		iroup Art Unit	234 17 65	
			Etre.	U.S. PATENT BOCUMENTS	!-			
AMINER NITIAL	REP	DOCUMENT NUMBER	DATE	NAME	CLASS	SURCLASS	FILING DATE IF APPROPRIATE	
SA	1.	5,623,243	4/22/97	Watanabe et al.	257	309		
				COPY OF PAPERS ORIGINALLY FILED				
						-10		
						1789	RHC	
			ļ			;-	RECEIVE	
			<u> </u>			AE	VED 2002	
						MOON		
				FOREIGN PATENT DOCUMEN	TS .			
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO	
							ļ	
							5	
		· · ·		OTHER DOCUMENTS (Inch	iding Author, Title,	Date, Peruncia P	ages, cac)	

XAMIN	ER <	Shamim A	hmed	DATE CONSIDERE	3/6	:103		
		ities if citation considered, wheth	er or not citation	is in conformance with MPEP Section	609; Draw line thr	ough citation if n	ot in conformance	

Form PTO-A820 (also form PTO-1449)

POSAVREVD4